

<b>Notice of References Cited</b>	Application/Control No. 10/660,575	Applicant(s)/Patent Under Reexamination CHIANG ET AL.	
	Examiner Kenneth A. Parker	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,914,761	06-1999	Ohe et al.	349/132
	B	US-3,736,047	05-1973	Gelber et al.	349/137
	C	US-4,248,502	02-1981	Bechteler et al.	349/137
	D	US-4,505,547	03-1985	Sekimura, Nobuyuki	349/137
	E	US-4,521,079	06-1985	Leenhouts et al.	349/137
	F	US-4,556,288	12-1985	Sekimura, Nobuyuki	349/137
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.